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## What is claimed is:

- 1 1. A semiconductive power cable composition comprising:
- a. a mixture of a high-temperature polymer and a soft polymer; and
- b. a conductive filler,
- 4 wherein a semiconductive cable layer prepared from the composition strippably
- 5 adheres to a second cable layer.
- 1 2. The semiconductive power cable composition of Claim 1, wherein the
- 2 semiconductive cable layer having a heat resistance of less than 100% as measured by
- a Hot Creep test at a testing temperature of 150 degrees Centigrade.
- 4 3. The semiconductive power cable composition of Claim 1 wherein the high-
- 5 temperature polymer and the soft polymer have different heat resistance.
- 1 4. The semiconductive power cable composition of Claim 1 wherein the high-
- 2 temperature polymer is selected from the group consisting of polypropylenes,
- 3 polyesters, nylons, polysulfones, and polyaramides and the soft polymer is selected
- from the group consisting of polyethylenes, polypropylenes, polyesters, and rubbers.
- 1 5. The semiconductive power cable composition of Claim 4 wherein the high-
- temperature polymer is a polypropylene and the soft polymer is a polyethylene.
- 1 6. The semiconductive power cable composition of Claim 5 wherein the
- 2 polyethylene is a copolymer of a polar monomer and a nonpolar monomer.
- 1 7. The semiconductive power cable composition of Claim 1 wherein the
- 2 conductive filler is selected from the group consisting of carbon blacks, carbon fibers,
- 3 carbon nanotubes, graphite particles, metals, and metal-coated particles.
- 1 8. The semiconductive power cable composition of Claim 1 wherein the second
- 2 cable layer being chemically-crosslinked.
- 1 9. The semiconductive power cable composition of Claim 1, further comprising a
- 2 curing agent.
- 1 10. The semiconductive power cable composition of Claim 1 further comprising a
- 2 coupling agent.
- 1 11. The semiconductive power cable composition of Claim 10 wherein the
- 2 coupling agent reduces the amount of a curing agent required to impart heat resistance
- 3 to the semiconductive cable layer.
- 1 . 12. The semiconductive power cable composition of Claim 11 further comprising
- 2 a curing agent.

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1 13. The semiconductive power cable composition of Claim 1 wherein the mixture

- 2 further comprises a compatibilizing polymer.
- 1 14. A semiconductive cable layer prepared from the semiconductive power cable
- 2 composition of Claim 1.
- 1 15. A power cable construction prepared by applying the semiconductive cable
- 2 layer of Claim 14 over a wire or cable.
- 1 16. A process for preparing a semiconductive power cable composition
- 2 comprising the step of:
- blending a mixture of a high-temperature polymer, a soft polymer, and a
- 4 conductive filler,
- 5 wherein a semiconductive cable layer prepared from the composition strippably
- 6 adheres to a second cable layer.
- 1 17. The process of Claim 16, wherein the mixture further comprises a coupling
- 2 agent.
- 1 18. A process for preparing a semiconductive power cable composition
- 2 comprising the steps of:
- a. reactively-coupling a mixture of a high-temperature polymer, a soft
- 4 polymer, and a coupling agent, in the presence of a conductive filler, wherein
- 5 the coupling agent reduces the amount of a curing agent required to impart
- heat resistance to a semiconductive cable layer prepared from a mixture of the
- high-temperature polymer, the soft polymer, and the conductive filler in the
- 8 absence of the coupling agent; and
- 9 b. admixing a curing agent,
- wherein a semiconductive cable layer prepared from the composition strippably
- adheres to a second cable layer.
- 1 19. A process for preparing a power cable comprising the steps of:
- a. extruding a semiconductive power cable composition comprising a
- mixture of a high-temperature polymer, a soft polymer, and a conductive filler,
- 4 over a metallic conductor to yield a semiconductive cable layer over the
- 5 metallic conductor; and
- b. extruding a polymer-dielectric insulation over the semiconductive
- 7 cable layer.

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1 20. The process for preparing a power cable of Claim 19 further comprising the step of

- c. extruding a second semiconductive power cable composition over the polymer-dielectric insulation to yield a second semiconductive cable layer.
- 1 21. A process for preparing a power cable comprising the steps of:
- a. extruding a power cable semiconductive composition comprising a mixture of a high-temperature polymer, a soft polymer, and a conductive filler,
- over a metallic conductor to yield a semiconductive cable layer over the
- 5 metallic conductor;
- b. extruding a chemically-crosslinkable insulation composition over the
  semiconductive cable layer;
- 8 c. extruding a second semiconductive power cable composition over the
- 9 polymer-dielectric insulation to yield a second semiconductive cable layer;
- 10 and
- d. crosslinking the chemically-crosslinkable insulation composition to yield a crosslinked, polymer-dielectric insulation.